

<b>Notice of References Cited</b>	Application/Control No. 10/615,062	Applicant(s)/Patent Under Reexamination KWON, HYUG-JIN	
	Examiner Sylvia R. MacArthur	Art Unit 1763	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2005/0173068	08-2005	Chen et al.	156/345.33
*	B	US-2003/0213436	11-2003	Kwon, Hyung-Jin	118/725
*	C	US-2003/0121608	07-2003	Chen et al.	118/715
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	J	US-			
	K	US-			
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	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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